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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:

Applicant : James A. Harrington, and Veena Gopal
Serial No. : 10/764,101
Filed : January 23, 2004
For : A METHOD, AND ARTICLE OF THE
METHOD, FOR FABRICATING A
FLEXIBLE, HOLLOW WAVEGUIDE
Examiner : Unknown
Art Unit : 2874
Confirmation No. : 7908
Attorney Docket No. : 879.1.018

I HEREBY CERTIFY THAT THIS CORRESPONDENCE IS BEING DEPOSITED WITH THE UNITED STATES POSTAL SERVICE AS
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June 27, 2006

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INFORMATION DISCLOSURE STATEMENT

Dear Sir:

Transmitted herewith is an Information Disclosure Statement ("IDS") in the above-referenced Application, together with a Form-1449 listing all references cited and copy of each non-US Patent/Application reference.

No Office Action on the above-referenced Application has been received by Applicant, and therefore no fee for submitting this IDS is believed to be due. However, the Commissioner is hereby authorized to charge Deposit Account No. 23-0510 if any fee under 37 C.F.R. 1.17 is deemed necessary for the accompanying references to be considered by the Patent and Trademark Office.

All the references are in English and/or are cited in an accompanying English language version of the Search Report by another Patent Office, so that comment on the references by the Applicant is not required under 37 C.F.R. § 1.98(a).

Respectfully submitted,

A handwritten signature in black ink that reads "Kenneth Watov". The signature is written in a cursive, flowing style.

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SERIAL NO. 10/764,101

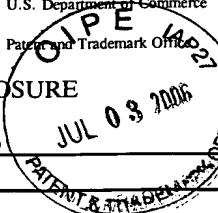
APPLICANT(S) James A. Harrington, and Veena Gopal

INFORMATION DISCLOSURE
CITATION

(Use several sheets if necessary)

FILING DATE January 23, 2004

GROUP 2874



U.S. PATENT DOCUMENTS

Examiner Initial	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE
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						YES NO

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Examiner

DATE CONSIDERED

* EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.